Search Notes

Application/Control No.	_

Applicant(s)/Patent under Reexamination
TAKAHASHI, AKIRA

10/720,140 Examiner

Art Unit

Michael J. Kyle

3677

SEARCHED				
Class	Subclass	Date	Examiner	
292	201,216, dig.23,210, dig.22,	6/16/2005	MK	
292	dig.65	6/16/2005	MK	
70	279.1,264	6/16/2005	MK	
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
C. Boswell for cl 292 and 70 searches	6/16/2005	МК		
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